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CLAIMS

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WHAT IS CLAIMED IS:

- 1. A raised microstructure for use in a silicon based device, the raised microstructure comprising:
- 5 a generally planar thin-film;
 - a sidewall supporting the film;
 - wherein the sidewall has at least one rib formed therein.
 - 2. The raised microstructure of claim 1 wherein the sidewall is corrugated.
 - 3. The raised microstructure of claim 1 wherein the rib has a generally arcuate cross section.
 - 4. The raised microstructure of claim 1 wherein the rib has a generally triangular cross section.
 - 5. The raised microstructure of claim 1 wherein the rib has a generally rectangular cross section.
- 15 6. The raised microstructure of claim 1 wherein the thin-film comprises one plate of a silicon based capacitive transducer.
 - 7. The raised microstructure of claim 1 wherein the thin-film comprises a rigid backplate of a silicon based microphone.
 - 8. A silicon based electret microphone having a backplate comprising:
 - a generally planar thin-film;
 - a sidewall supporting the film;
 - wherein the sidewall has at least one rib formed therein.
 - 9. The microphone of claim 8 wherein the sidewall is corrugated.
 - 10. The microphone of claim 8 wherein the rib has a generally arcuate cross section.
- 25 11. The microphone of claim 1 wherein the rib has a generally triangular cross section.
 - 12. The microphone of claim 1 wherein the rib has a generally rectangular cross section.
 - 13. The microphone of claim 8 wherein the sidewall includes a plurality of ribs.
 - 14. The microphone of claim 13, wherein the ribs are equally spaced about the sidewall.
- 30 15. A raised microstructure for use in a silicon based device, the raised microstructure comprising:

a generally planar element with a first thickness and a periphery;

a sidewall with a second thickness;

said sidewall supporting said planar element at said periphery above a substrate at a distance;

wherein said sidewall has a plurality of ribs formed therein.

- 16. The raised microstructure of claim 15 wherein said first thickness is small compared to the lateral extent of the said planar element.
- 17. The raised microstructure of claim 15 wherein said second thickness is approximately equal to the said first thickness.
- 18. The raised microstructure of claim 15 wherein said distance is large compared to said second thickness.
 - 19. The raised microstructure of claim 15 wherein the ribs follow a periodic path of the periphery, inwards and outwards with respect to the centroid of the planar element.
 - 20. The raised microstructure of claim 19 wherein the path is arcuate.